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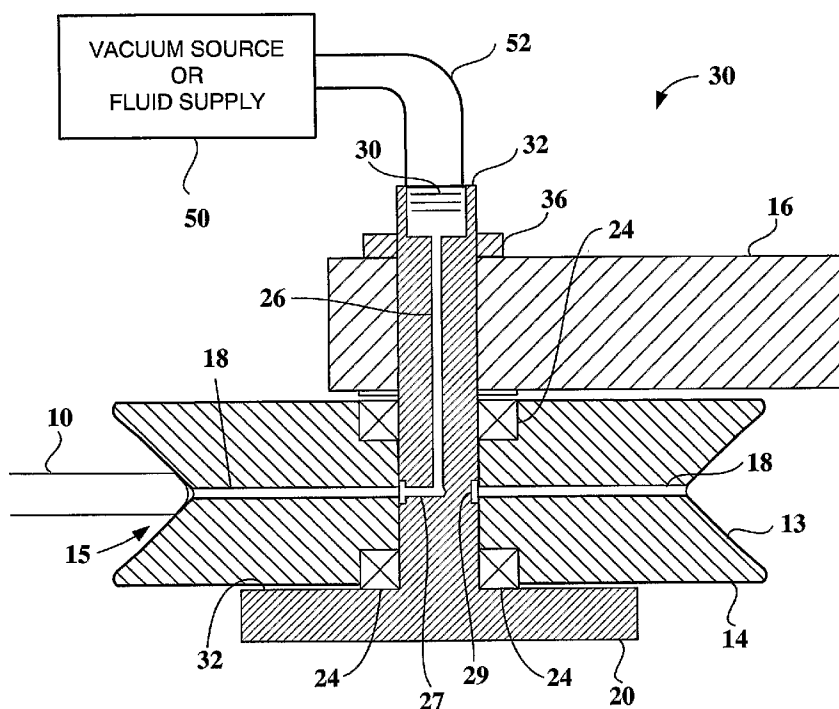
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(54) Title: **WAFER EDGE WHEEL WITH DRYING FUNCTION**



(57) Abstract: An edge wheel for supporting and rotating a disk-shaped substrate includes a wheel body having a peripheral groove configured to support and edge of a substrate and at least one radial channel extending into said wheel body from said peripheral groove. An edge wheel dryer and a method for processing a disk-shaped substrate are also described.

WO 2006/039127 A3



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